

Substitute Form PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office		Attorney's Docket No. 12732-061002		Application No. New Divisional Application <i>10/792132</i>	
Information Disclosure Statement by Applicant (Use several sheets if necessary)				Applicant Taketomi Asami et al.		Filing Date March 4, 2004	
(37 CFR §1.98(b))				Group Art Unit <i>2818</i>			

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
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Examiner Signature <i>JOSEPH NZUKEN</i>	Date Considered <i>1/19/05</i>
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EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

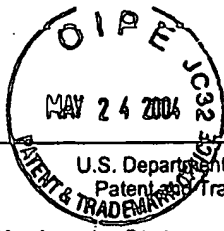
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Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
<u>SN</u>	ABB	6,690,068	02/10/2004	Yamazaki et al.			

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<u>SN</u>	AKK	R. Ishihara et al.; "Microtexture Analysis of Location Controlled Large Si Grain Formed by Excimer-Laser Crystallization Method"; <u>Active-Matrix Liquid-Crystal Displays 1999</u> ; TFT Technologies and Related Materials; Digest of Technical Papers; Kogakuin University, Tokyo, Japan; July 14-16, 1999
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Examiner Signature	<u>JOSEPH NGUYEN</u>	Date Considered	<u>1/19/05</u>
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	AM							
	AN							
	AO							
	AP							

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	AS	
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